



I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Assistant Commissioner for Patents Washington, D.C. 20231
on December 16, 1999

By: Glynda Polisch

#7 EXT 1-12-99
PATENT
Attorney Docket No.: AM524R1/T28900
TTC No.: 16301-028900

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

KATSUYUKI MUSAKA et al.

Application No.: 09/187,551

Filed: November 5, 1998

For: METHOD FOR FORMING A THIN
FILM FOR A SEMICONDUCTOR DEVICE

Examiner: Marianne Padgett

Art Unit: 1762

PETITION TO EXTEND TIME

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant petitions the Assistant Commissioner of Patents to extend the time for response to the Office Action dated July 16, 1999 for two (2) months, from October 16, 1999 to December 16, 1999. An appropriate response in the form of an Amendment is enclosed herewith.

Please charge the fee of \$380.00 to the undersigned's Deposit Account No. 20-1430. Please charge any additional fees or credit overpayment to the above deposit account. This petition is submitted in triplicate.

Respectfully submitted,

Chun-Pok Leung
Reg. No. 41,405

TOWNSEND and TOWNSEND and CREW LLP
Tel: (650) 326-2400
Fax: (650) 326-2422
RL:llr
PA 3039988 v1

RECEIVED
DEC 28 1999
TC 1700 MAIL ROOM

12/23/1999 NSHIFERA 00000072 201430 09187551
380.00 CH
01 FC:116